00684.002728.

## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		)		6 7 70
Tomoharu HASE		:	Examiner: H. Nguyen	2000
Application No.: 09/145,982		: )	Group Art Unit: 2851	
Filed: September 3, 1998		)		OCA
For:	EXPOSURE APPARATUS AND DEVICE MANUFACTURING METHOD INCLUDING GAS PURGING OF A SPACE CONTAINING OPTICAL COMPONENTS	· ) : ) :	December 26, 2002 (Thursday After Holiday)	#33 1-2-03 UN

The Commissioner for Patents Washington, D.C. 20231

## REQUEST FOR RECONSIDERATION WITH PETITION FOR EXTENSION OF TIME

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated June 25, 2002, for three months from September 25, 2002, up to and including December 26, 2002. A check in the amount of \$920.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, or credit any overpayment, to Deposit Account 06-1205.

12/27/2002 SSESHE1 00000044 09145982

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920.00 DP